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10-11-01  
03085

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: Byung Jin Choi et al.

Docket No.: 1500-2002

Serial No: 09/698,317

Art Unit: \_\_\_\_\_

Filed: December 27, 2000

Examiner: \_\_\_\_\_

Entitled: HIGH PRECISION ORIENTATION ALIGNMENT AND GAP  
CONTROL STAGES FOR IMPRINT LITHOGRAPHY

AMENDMENT BEFORE FIRST OFFICE ACTION

Assistant Commissioner For  
Patents  
Washington, DC 20231

|   |         |
|---|---------|
| MAILING CERTIFICATE UNDER 37 C.F.R. §1.8(a)   |         |
| I hereby certify that the above correspondence is being deposited with the U.S. Postal Service as First Class Mail in an envelope addressed to: Asst. Commissioner for Patents, Washington, D.C. 20231 by the person and on the date indicated below. |         |
| Date  | 6-22-01 |
| <i>Theresa Van Zandt</i>  |         |
| Theresa Van Zandt   |         |

Dear Sir:

This is an amendment before first office action to the above referenced application. Please amend the application as follows:

IN THE CLAIMS:

Please cancel claims 1 - 12.

RECEIVED  
JUL - 6 2001  
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